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CORRESPONDENCE DATA	
Fax Number:	(703)292-9041
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
Email:	nsfpatents@nsf.gov
Correspondent Name:	NATIONAL SCIENCE FOUNDATION
Address Line 1:	4201 WILSON BLVD
Address Line 2:	ROOM 1265
Address Line 4:	ARLINGTON, VIRGINIA 22230
NAME OF SUBMITTER:	DANA THIBODEAU
SIGNATURE:	/DT/
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Invention Title: A Method for Generating Segregated Thin Film Multilayers by Use of Material

Phase Segregation

Inventor(s): Vladimir Bulovic, Wing-Keung Woo, Seth Coe-Sullivan, Mounqi G. Bawendi

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Foreign Applications filed/intended in (countries): _____

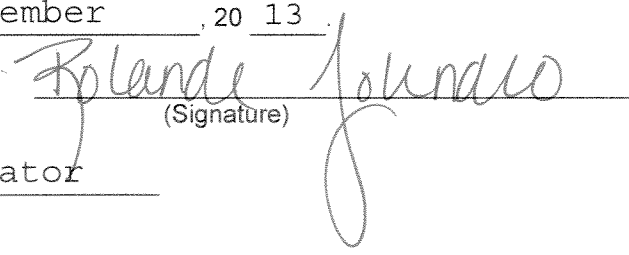
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At MIT Technology Licensing Office NE18-501 One Cambridge Center, Kendall Square

Cambridge, MA 02142 US
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